

Title (en)

VACUUM ELECTRON BEAM ARRANGEMENT AND METHOD FOR PRODUCING AN ELECTRODE THEREFOR

Title (de)

VAKUUM-ELEKTRONENSTRAHLANORDNUNG UND VERFAHREN ZUR HERSTELLUNG EINER ELEKTRODE DAFÜR

Title (fr)

DISPOSITIF À FAISCEAU D'ÉLECTRONS À VIDE ET PROCÉDÉ POUR RÉALISER UNE ÉLECTRODE DESTINÉE À CELUI-CI

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Application

EP 12766910 A 20120827

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Abstract (en)

[origin: WO2013045183A1] In order to reduce the secondary electron emission in a vacuum electron beam arrangement, in particular a travelling wave tube (TWT), a surface structure with an open-pore surface layer (OS) and a method for producing such a surface structure are described.

IPC 8 full level

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